Notice of Allowability	Application No.	Applicant(s)
	10/719,663	FARIS, SADEG M.
	Examiner	Art Unit
	Dao H. Nguyen	2818
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	pears on the cover sheet with the S (OR REMAINS) CLOSED in this S) or other appropriate communicat RIGHTS. This application is subject	e correspondence address application. If not included ion will be mailed in due course. THIS
1. X This communication is responsive to <u>02/21/2006</u> .		
2. 🛮 The allowed claim(s) is/are <u>1-5</u> .	•	
 Acknowledgment is made of a claim for foreign priority of a) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have a copies of the priority documents have a copies of the priority documents have a copies of the certified copies of the priority documents have a copies of the certified copies of the priority documents have a copie	ve been received. ve been received in Application No.	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		ply complying with the requirements
 A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which given 		
5. CORRECTED DRAWINGS (as "replacement sheets") mu	ust be submitted.	
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached		
1) 🗌 hereto or 2) 🔲 to Paper No./Mail Date	<u> -</u> -	·
(b) including changes required by the attached Examiner Paper No./Mail Date	r's Amendment / Comment or in the	e Office action of
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in		
 DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT 		
Attachment(s)		·
1. Notice of References Cited (PTO-892)	<u>=</u>	Il Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summa Paper No./Mail I	
 Information Disclosure Statements (PTO-1449 or PTO/SB/ Paper No./Mail Date 	/08), 7. ⊠ Examiner's Amer	ndment/Comment
 Examiner's Comment Regarding Requirement for Deposit of Biological Material 	8. 🖾 Examiner's State 9. 🗖 Other David Nelms	ment of Reasons for Allowance
Supervisory Patent Examiner Technology Center 2800		

DETAILED ACTION

1. This Office Action is in response to the communications dated 02/21/2006.

Claims 1-13 are active in this application.

Claim(s) 6-13 have been withdrawn.

Examiner's Amendment

- 2. An examiner's amendment to the record appears below. Should the changes and /or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.3.12. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.
- a. In claim 1, line 12, the phrase "said buried oxide **payer**" has been changed to –said buried oxide **layer** to correct clerical error.
- b. This application is in condition for allowance except for the presence of claims 6-13 to invention(s) non-elected without traverse. Accordingly, claim(s) 6-13 have been cancelled.

Reason for Allowance

3. The following is an examiner's statement of reason for allowance:

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None of the references of record teaches or suggests the claimed method of fabricating a vertically integrated circuit comprising (in addition to the other limitations in the claim) selectively creating strong bond regions and weak bond regions on a bulk substrate; providing a first bonded semiconductor layer vertically supported on the substrate; creating semiconductor device portions on the first bonded semiconductor layer, wherein the semiconductor device portions corresponding to the weak bond regions; and removing the first semiconductor layer from the bulk substrate (claims 1, 4).

4. Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

5. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Dao Nguyen whose telephone number is (571)272-1791. The examiner can normally be reached on Monday-Friday 9:00am – 6:00pm. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571)272-1787. The fax numbers for all communication(s) is 571-273-8300.

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Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (571)272-1625.

Dao H. Nguyen Art Unit 2818 March 30, 2006 David Nelms
Supervisory Patent Examiner
Technology Center 2800